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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

5    Applicant:            Chih-Ning Wu            Examiner:            Umez Eronini, Lynette T  
     Filing Date:        07/16/2001            Art Unit:            1765  
     App. No.:            09/682,054            Docket No.:        NAUP0374USA

10    Title:                EXTRUSION-FREE WET CLEANING PROCESS FOR COPPER-DUAL  
                             DAMASCENE STRUCTURES

     To:                Commissioners for Patents  
                             P.O. Box 1450  
                             Alexandria, VA 22313-1450

15    Subject:            Response to the Office communication (Notice of Non-Compliant  
                             Amendment) dated 06/19/2003

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Dear Sir or Madame:

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**INTRODUCTORY COMMENTS**

     In reply to the Office communication identified above, a new version of  
     AMENDMENT that complies with the guidelines of the voluntary revised amendment  
     practice is respectfully submitted to replace the prior version AMENDMENT filed  
30    06/12/2003. Entering of the new version AMENDMENT herein and consideration of all  
     amendments are politely requested.